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|-----------------------------------|---------------------------------------|--|-------------|
| Notice of References Cited | Application/Control No. 10/792,322 | Applicant(s)/Patent Under Reexamination LEE ET AL. | |
| | Examiner Li Liu | Art Unit 2613 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-------------------|----------------|
| * | A | US-2003/0142978 | 07-2003 | Lee et al. | 398/34 |
| * | B | US-6,847,758 | 01-2005 | Watanabe, Shigeki | 385/27 |
| * | C | US-2001/0004290 | 06-2001 | Lee et al. | 359/124 |
| * | D | US-2002/0196491 | 12-2002 | Deng et al. | 359/124 |
| * | E | US-2003/0206740 | 11-2003 | Lee et al. | 398/79 |
| * | F | US-2005/0163503 | 07-2005 | Lee et al. | 398/019 |
| * | G | US-2004/0234195 | 11-2004 | Pohjola et al. | 385/024 |
| * | H | US-2003/0058500 | 03-2003 | Sugawara, Mitsuru | 359/135 |
| * | I | US-5,559,624 | 09-1996 | Darcie et al. | 398/72 |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | H.D. Kim: "A Low-Cost WDM Source with and ASE Injected Fabry-Perot Semiconductor Laser", IEEE Photonics Technology Letters, Vol. 12, No. 8, August 2000, page 1067-1069 |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.